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T-871 P.02 F-006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Shih-Ming Wang

Group Art Unit: 2814

Serial No.: 09/974,584

Examiner: Pham, Long

Filed:

Oct. 9, 2001

In Response to Office Action

Dated: Feb

Feb. 5, 2003

For:

Method for Depositing Silicon Oxide Incorporating an Outgassing Step

Attorney Docket No.: 67,200-318

Certificate of Facsimile

I hereby certify that this paper (along with any tempered to as being attached or enclosed) is being faxed to (703) 872-8318 on the date shown below

Date: May 5, 2003

RESPONSE TO OFFICE ACTION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to an Office Action mailed Feb. 5, 2003, please enter the following amendments and consider the following remarks.



Date:

May 5, 2003

TO:

Pham, Long Examiner

(703) 872-9318

Art Unit: 2814

FAX Operator:

Kathy Dixon

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(248) 540-4035

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Subject Matter:

09/974,584

Attorney Doc: 67,200-318

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